

PATENT  
0171-1100PUS1

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Takeru WATANABE et al. Conf.:  
Appl. No.: NEW Group:  
Filed: May 20, 2004 Examiner:  
For: BASIC COMPOUND, RESIST COMPOSITION AND  
PATTERNING PROCESS

PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

May 20, 2004

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

This amendment includes: Amendments to the Specification; and Remarks.